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FACSIMILE COVER SHEET

To: Examiner George A. Goudreau Technology Center 1700	Total Pages Sent: 3 (including cover sheet)
Facsimile Number: (571) 273-8300	Transmission Date: February 22, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Luetzen, *et al.* Docket No.: INF115
Serial No: 10/721,225 Art Unit: 1763
Date Filed: November 26, 2003
Title: Method and Structures for Increasing the Structure Density and the Storage Capacitance in a Semiconductor Wafer

CERTIFICATION OF FACSIMILE TRANSMISSION

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- Certification of Facsimile Transmission (1 page)
- Information Disclosure Statement (1 page)
- PTO/SB/08A with 1 reference cited (1 page)

Respectfully submitted,



Kristin R. Hayes
Legal Assistant

Confirmation Respectfully Requested

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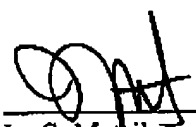
INFORMATION DISCLOSURE STATEMENT

Applicant wishes to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO/SB/08A that may be considered material to the examination of the above-identified application. A copy of the U.S. Patent cited is not being submitted.

No fee is due at this time, as this Information Disclosure Statement is being filed pursuant to 37 C.F.R. § 1.97(b)(3), before the mailing of a first Office action on the merits.

Respectfully submitted,

February 22, 2006
Date


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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Application Number	10/721,225
				Filing Date	November 28, 2003
				First Named Inventor	Luetzen, et al.
				Art Unit	1763
				Examiner Name	Goudreau, George A.
				Attorney Docket Number	INF115
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